IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: Helen Shibru
Shinji Ohnishi)	
	:	Group Art Unit: 2621
Appln. No.: 10/716,663)	
	:	Confirmation No.: 7434
Filed: November 20, 2003)	
	:	
For: REPRODUCTION APPARATUS AND)	
RECORDING APPARATUS, AND	:	
CONTROLLING METHOD THEREOF)	June 28, 2007

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

FOURTH INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents, other than U.S. patent documents, are enclosed.

REMARKS

As an initial matter, Applicant wishes to advise the Examiner that the October 14, 2005 Information Disclosure Statement inadvertently erroneously refers to the "Korean" Patent Office and Patent Application, which references should be to --Chinese--. Favorable consideration is earnestly solicited.

Further, attached are (a) a partial translation of the June 1, 2007 Chinese Official Action, and (b) a translation of JP-A 2000-41218, both of which were cited in the June 13, 2007 Information Disclosure Statement.

WO 02/47087 A1 was published from the international application corresponding to US 2003/0118158 A1 (<u>Hattori</u>), which was applied in the June 19, 2007 Official Action.

FORMAL MATTERS

Any fee required in connection with this paper should be charged to Deposit Account No. 06-1205.

CONCLUSION

It is respectfully requested that the cited information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be initialed and returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Washington D.C. office by

telephone at (202) 530-1010. All correspondence should continue to be directed to our address

given below.

Respectfully submitted,

/Daniel S. Glueck/

Daniel S. Glueck Attorney for Applicant

Registration No. 37,838

FITZPATRICK, CELLA, HARPER & SCINTO

30 Rockefeller Plaza

New York, New York 10112-3800

Facsimile: (212) 218-2200

3

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S)		ATTY DOCKET NO. 03500.017723		APPLICATION NO. 10/716,663					
		APPLICANT Shinji Ohnishi							
(Use several sheets if necessary) Date Submitted to USPTO: June 28, 2007			FILING DATE November 20, 20	GROUP					
U.S. PATENT DOCUMENTS									
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE			
				1					
				1	1				
				1					
		<u> </u>		\top					
				\dagger					
				\dagger					
		FOREIGN	I PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT			
/HS/	2000-41218	02/08/2000	Japan			Yes			
/HS/	WO 02/047087	06/13/2002	PCT			Abstract			
				\perp					
	OTHER	DOCUMENT(S) (Inch	uding Author, Title, Date, Pertinent Pag	ges, Etc.)					
	June 20, 2007 Chinese Official Action (with English language partial translation)								
EXAMINER	/Helen Shibri	 u /	DATE CONSIDERED 01/04/2008						

Sheet 1 of 1

DSG/mcm

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.